

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

INFORMATION DISCLOSURE STATEMENT

APPLICANT(S):	Koji Naniwada	ATTY DOCKET NO.: 09792909-6633
SERIAL NO.:	Unknown	GROUP ART UNIT: Unknown
DATE FILED :	March 14, 2006	EXAMINER: Unknown
INVENTION:	“RESONATOR OF MICROELECTROMECHANICAL SYSTEMS, ITS DRIVING METHOD, ITS MANUFACTURING METHOD AND FREQUENCY FILTER”	

Mail Stop: PCT  
 Commissioner for Patents  
 P.O. Box 1450  
 Alexandria, VA 22313-1450

SIR:

In accordance with the provisions of 37 C.F.R. § 1.56, Applicants request that citation and examination of the references identified on the attached PTO-1449 form, copies of which are enclosed herewith in accordance with 37 C.F.R. §1.98, be made during the course of examination of the above-referenced application for United States Letters Patent.

I. SUBMITTED US PATENT REFERENCES

<u>Number</u>	<u>Inventor(s)</u>	<u>Date of Publication</u>
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II. SUBMITTED FOREIGN PATENT REFERENCES

	<u>Number</u>	<u>Country</u>	<u>Date of Publication</u>
AH	WO 01/82479 A2	PCT	November 1, 2001
AI	WO 00/42705 A2	PCT	July 7, 2000

III. OTHER ITEMS OF INFORMATION

AU MUSTAFA U. DEMIRICI and CLARK T. -C NGUYEN; Higher-Mode Free-Free Beam Micromechanical Resonators; 2003 IEEE International Frequency Control Symposium and PDA Exhibition

10/571723  
IAP9REC/CPCT/PFO 14 MAR 2006

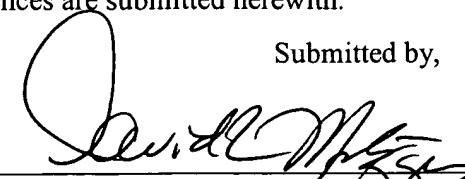
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IV. EXPLANATION OF RELEVANCE

The above-identified references were cited in the International Search Report January 11, 2005, in counterpart application No. PCT/JP2004/014010. Copies of the International Search Report and references are submitted herewith.

Submitted by,

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37 CFR 1.501 INFORMATION DISCLOSURE STATEMENT IN A PATENT (use several sheets if necessary)		Docket No. 09792909-6633 10/571723
		Applicants: Koji Naniwada
		Filing Date March 14, 2006
		Group Art Unit

**U.S. PATENT DOCUMENTS**

Examiner's Initials		Document Number	Date	Name	Class	Subclass	Filing Date If appropriate
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						

**FOREIGN PATENT DOCUMENTS**

		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AH	WO 01/82479 A2	11/01/2001	PCT				
	AI	WO 00/42705 A2	07/20/2000	PCT				
	AJ							
	AK							
	AL							
	AM							
	AN							
	AO							
	AP							
	AQ							
	AR							
	AS							
	AT							

**OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)**

	AU	MUSTAFA U. DEMIRICI and CLARK T. -C NGUYEN; Higher-Mode Free-Free Beam Micromechanical Resonators; 2003 IEEE International Frequency Control Symposium and PDA Exhibition
	AV	
	AW	
	AX	
	AY	
	AZ	

Examiner Date Considered

**\*EXAMINER:** Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.